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Amendments to the Claims:

(Currently Amended) A PVD process for coating substrates, wherein the substrate is pre-1.

treated in the vapour of a pulsed, magnetic field-assisted cathode sputtering operation, and during

pre-treatment a magnetic field arrangement of the a magnetron cathode type, with a strength of

the horizontal component in front of the target of 100 to 1500 Gauss, is used for magnetic field-

assistance, and wherein after pre-treatment further coating is effected by means of cathode

sputtering, with the power density of the pulsed discharge during pre-treatment being greater than

1000 W.cm⁻².

2. (Original) A process in accordance with Claim 1 wherein the power density falls within

the range from 2000 to 3000 W.cm⁻².

3. (Currently Amended) A process in accordance with Claim 1 wherein the a pulse duration

(on-time) ranges between 10 and 1000 µs, and that the a pulse interval (repetition period) is

between 0.2 ms and 1000 s.

4. (Original) A process in accordance with Claim 1 wherein the pulse duration is 50 µs and

the pulse interval is 20 ms.

5. (Currently Amended) A process in accordance with Claim 1 wherein the

magnetron discharge, which is of the magnetron discharge type, is distributed over the a cathode

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surface area and occupies at least 50 % of the surface area.

6. (Currently Amended) A process in accordance with Claim 5 wherein the discharge is

distributed over 70-90 % of the a cathode surface area.

7. (Currently Amended) A process in accordance with Claim 1 wherein the an average

pulsed discharge current density is less than 10 A.cm².

8. (Currently Amended) A process in accordance with Claim 1 wherein the a localise 1

maximum pulsed discharge current density is less than 100 A.cm⁻².

9. (Currently Amended) A process in accordance with Claim 1 wherein the pulses which

are generated have a peak voltage from 0.5 to 2.5 kV.

10. (Currently Amended) A process in accordance with Claim 1 wherein pre-treatment with

a magnetic field-assisted cathode sputtering is conducted in a non-reactive atmosphere, e.g. in

selected from a group consisting of Ne, Ar, Kr or and Xe, with targets made which included

material selected from a group consisting of Cr, V, Ti, Zr, Mo, W, Nb or and Ta.

11. (Original) A process in accordance with Claim 1 wherein pre-treatment is effected with

Ar in the pressure range from 10^{-5} to 10^{-1} mbar.

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12. (Original) A process in accordance with Claim 1 wherein pre-treatment is effected with

Ar at a pressure of 10⁻³ mbar.

13. (Original) A process in accordance with Claim 1 wherein during pre-treatment a negative

bias voltage within the range from 0.5 to 1.5 kV is applied to the substrates, so that an etcling or

cleaning process is initiated simultaneously with an ion implantation process (ABS technique).

14. (Original) A process in accordance with Claim 13 wherein the negative bias voltage is

pulsed with pulse widths of 2 µs to 20 ms and a pulse interval which is likewise 2 µs to 20 ms.

15. (Original) A process in accordance with Claim 1 wherein the coating formed by cathode

sputtering consists of the nitrides TiN, ZrN, TiAlN, TiZrN, TiWN, TiNbN, TiTaN, TiBN or the

carbonitrides TiCN, ZrCN, TiAlCN, TiZrCN, TiVCN, TiNbCN, TiTaCN or TiBCN.

16. (Currently Amended) A process in accordance with Claim 15 1 wherein the coating

contains 0.1 to 5 atomic % of the rare earth elements an element selected from the group of Sc.

Y, La or and Ce.

17. (Currently Amended) A process in accordance with Claim 1 wherein the coatings consist

of fine (nanometre-scale) multi-layer coatings with a periodicity of 1 to 10 nm, from the group

comprising TiN/TiAlN, TiN/VN, TiN/NbN, TiN/TaN, TiN/ZrN, TiAlN/CrN, TiAlN/ZrN,

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TiAIN/VN, CrN/NbN, CrN/TaN, CrN/TiN, Cr/C, Ti/C, Zr/C, V/C, Nb/C or Ta/C.

18. (Currently Amended) A process in accordance with Claim 16 17 wherein one of the cited

individual layers contains 0.1 to 5 atomic % of the rare earth elements an element selected from

the group of Sc, Y, La or and Ce.

19. (Currently Amended) A process in accordance with Claim 16 17 wherein both of the

cited individual layers contain 0.1 to 5 atomic % of the rare earth elements an element selected

from the group of Sc, Y, La or and Ce.

20. (Currently Amended) A process in accordance with Claim 1 wherein the cathode

sputtering employed during coating is of the unbalanced magnetron type sputtering.

21. (Original) A process in accordance with Claim 1 wherein identical cathodes and identical

magnetic field arrangements are used for pre-treatment and coating.

22. (Currently Amended) A process in accordance with Claim 21 wherein specific

adaptations of the magnetic field strength are made, by adjusting the distance of the a magnet

array from the a target surface, in order to optimise the pre-treatment and coating operation s.

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23. (New) A PVD process for coating substrates, wherein the substrate is pre-treated in the

vapour of a pulsed, magnetic field-assisted cathode sputtering operation, and during pre-

treatment a magnetic field arrangement of a magnetron cathode, with a strength of the horizontal

component in front of the target of 100 to 1500 Gauss, is used for magnetic field-assistance, and

wherein after pre-treatment further coating is effected by means of cathode sputtering, with the

power density of the pulsed discharge during pre-treatment being greater than 200 W.cm-2.

24. (New) A process in accordance with claim 23 wherein magnetron discharge is distributed

over a cathode surface area and occupies at least 10% of the surface area.

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